TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

	Title of Invention	[METHOD FOR TREATING WAFER SURFACE]
١	Application Number :	
	Date :	
	First Named Applicant:	Mr. Chi-Long Tsal
	Confirmation Number:	
1	Attorney Docket Number:	10367-US-PA

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Submitted By:	Elec. Sign.	Sign. Capacity
Dr. Belinda Lee Registered Number: 46,863	/Belinda Lee/	Agent

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Documents being submitted:	Files
	10007
us-request	10367-usrequ.xml
	us-request.dtd us-request.xsl
us sesimment	10367-usassn.xml
us-assignment	us-assignment.xsl
	us-assignment.dtd
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	10367assignment1.tif
us-fee-sheet	10367assignment2.tif 10367-usfees.xml
us-ree-sneet	us-fee-sheet,xsl
	us-fee-sheet.dtd
de de service	10367declaration1.tif
us-declaration	10367declaration1.tif
us-declaration	10367-deciarationz.tii
application-body	
	us-application-body.xsl
	application-body.dtd
	wipo.ent
	mathml2.dtd
	mathml2-qname-1.mod isoamsa.ent
	isoamsb.ent
	isoamsc.ent
	isoamsn.ent
	isoamso.ent
	isoamsr.ent
	isogrk3.ent
	isomfrk.ent
	isomopf.ent
	isomscr.ent
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	isobox.ent
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	isocyr2.ent
	isodia.ent
	isolat1.ent
	isolat2.ent
	isonum.ent
	isopub.ent
	mmlextra.ent
	mmlalias.ent
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	10367us0002.tif
	10367us0003.tif
	10367us0004.tif
	10367us0005.tif
	10367us0006.tif
	10367us0007.tif
Comments	

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